

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

re application of:

Chih-Hsin Ko et al.

Appl. No. 10/816,562

Filed: April 1, 2004

For: CMOS Fabricated On Different

Crystallographic Orientation Substrates

Group Art Unit: 2815

Examiner: Diaz, Jose R.

Confirmation No.: 1238

Mail Stop AF Commissioner for Patents P. O. Box 1450 Alexandria, VA 22313-1450

## RESPONSE TO FINAL OFFICE ACTION MAILED NOVEMBER 21, 2005

## I. **Introductory Comments**

The present paper is being submitted in response to the final Office Action mailed November 21, 2005. No fees are believed necessary for consideration of the present paper. However, the Commissioner is hereby authorized to charge any necessary extension of time fees, and/or any other fees, to Haynes and Boone, LLP's Deposit Account No. 08-1394.

Listing of Claims begins on page 2 of this paper.

Remarks begin on page 7 of this paper.